

Search Notes

Application/Control No.

10/508,934

Examiner

Jean F. Duverne

Applicant(s)/Patent under
Reexamination

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Art Unit

2839

SEARCHED

Class	Subclass	Date	Examiner
439	701	9/29/2005	JFD
	607-610		
	603		
	579		
	687		
	696		
	687		
	660	9/29/2005	JFD

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR